




<b>FORM PTO-1449</b> <b>INFORMATION DISCLOSURE STATEMENT</b>				Atty. Docket  OHG 135		Application No.  10/660,490	
				Applicant Makoto TERUI			
				Filing Date November 28, 2003		Group 2812	
<b>U.S. PATENT DOCUMENTS</b>							
Examiner Initial		Document Number	Date	Name	Class	Sub-Class	Filing Date
<i>CAE</i>	AA	US 5,932,493	08/03/99	AKATSU et al.			
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
<b>FOREIGN PATENT DOCUMENTS</b>							
		Document Number	Date	Country	Class	Sub-Class	Translation
<i>CAE</i>	AI	7-275813	10/24/95	JAPAN			Abstract and Translation
	AJ						
	AK						
	AL						
	AM						
	AN						
<b>OTHER (Including Author, Title, Date, Pertinent Pages, etc.)</b>							
	AO						
Examiner <i>C. J. [Signature]</i>					Date Considered <i>4/5/05</i>		
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.							

<b>FORM PTO-1449</b> <b>INFORMATION DISCLOSURE STATEMENT</b> 	Atty. Docket: <b>OHG-125</b>	Application No.: <b>10/660,490</b>
	Applicant: <b>Noriko TOMITA et al.</b>	
	Filing Date: <b>September 12, 2003</b>	Group Art Unit: <b>2812</b>

**U.S. PATENT DOCUMENTS**

Examiner Initial		Document Number	Date	Name	Class	Sub-Class	Filing Date
<i>COL</i>	AA	6,165,956	12/26/00	Zhang et al.			
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						

**FOREIGN PATENT DOCUMENTS**

		Document Number	Date	Country	Class	Sub-Class	Trans - lation
<i>COL</i>	AI	2001-521285	06/11/01	Japan			No
	AJ						
	AK						
	AL						
	AM						

**OTHER (Including Author, Title, Date, Pertinent Pages, etc.)**

	AN	
	AO	

Examiner

*[Signature]*

Date Considered

*4/5/05*

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.

<b>FORM PTO-1449</b>  <b>INFORMATION DISCLOSURE STATEMENT</b>	Atty. Docket: <b>OHG-135</b>	Application No.: <b>Not yet assigned</b>
	Applicant: <b>Noriko TOMITA et al.</b>	
	Filing Date: <b>September 12, 2003</b>	Group Art Unit: <b>Not yet assigned</b>



### U.S. PATENT DOCUMENTS

Examiner Initial		Document Number	Date	Name	Class	Sub-Class	Filing Date
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						

### FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Sub-Class	Translation
	AI						
	AJ						
	AK						
	AL						
	AM						

### OTHER (Including Author, Title, Date, Pertinent Pages, etc.)

	AN	"Chemical Contamination in the semiconductor process environment and counter-measures therefor". Realize Inc., pp. 268-269 (page 6 of the specification)
	AO	"The current status of contamination in the ULSI fabricating". Realize Inc., pp. 378-383
Examiner	Date Considered <u>4/5/05</u>	

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.